



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Hellig, et al.

Title: SYSTEM FOR FORMING A SEMICONDUCTOR DEVICE AND METHOD THEREOF

App. No.: 10/058,854 Filed: 01/28/2002

Examiner: William M. Brewster Group Art Unit: 2823

Atty. Dkt. No.: 1458.TT4962

May 13, 2003

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

In response to the Office Action mailed February 4, 2003, regarding the above captioned patent application, the Applicants hereby respectfully submit the following amendment and response.

RECEIVED
MAY 29 2003
TC 2800 MAIL ROOM

05/23/2003 10:01:30 AM
HASFANI 00000094 10058854
H 00 081